

Obducat receives order for NIL system from a European Institute

OBDUCAT has received an order for an EITRE 3 nanoimprint lithography (NIL) system. The order value amounts to approximately SEK 2.1 million and delivery is planned for the second quarter of 2026.

The institute will use the EITRE 3 system for research and development of next-generation technologies in areas such as advanced computing and medical applications. The development of these technologies relies on extremely small and precise structures, and the EITRE 3 system provides the customer with the advanced manufacturing capabilities required to develop and test such solutions using both thermal and UV-based nanoimprint lithography.

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About Obducat AB (publ)

Obducat AB (publ) is an innovative developer and supplier of technologies, products and processes used for the production and replication of advanced micro and nano structures. Obducat's products and services serve the demands of customers worldwide within the LED and Display, Optics and Photonics, MEMS and Sensor industries as well as in High Power and High Frequency electronics and Biomedical Devices. Obducat's technologies include nano imprint technology, resist- and wet processing technologies. Obducat has its own market presence in Sweden, Germany, Japan, USA, England, Portugal and China and the headquarter is located in Lund, Sweden. Obducat is a public company. The Obducat share is traded on the Swedish NGM Main Regulated Equity exchange. Read more at www.obducat.com or contact us via email investorrelations@obducat.com

Attachments

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